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DOCKET NO: 263787US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
HIROSHI MASHIMA, ET AL. : EXAMINER: GAMBETTA, KELLY M.  
SERIAL NO: 10/518,371 :  
FILED: DECEMBER 28, 2004 : GROUP ART UNIT: 1792  
FOR: METHOD FOR PLASMA- :  
ENHANCED CHEMICAL VAPOR  
DEPOSITION AND APPARATUS FOR  
PLASMA-ENHANCED CHEMICAL  
VAPOR DEPOSITION

AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated February 11, 2009, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.